

**ATTORNEY DOCKET NO. HUTTEMAN 9-2**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Robert Hutteman, et al.  
Serial No.: N/A  
Filed: Herewith  
Title: THIN FILM RESISTOR DEVICE AND METHOD  
OF MANUFACTURE THEREFOR  
Grp./A.U.: N/A  
Examiner: N/A

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence, including the attachments listed, is being deposited with the United States Postal Service, Express Mail - Post Office to Addressee, Receipt No. <u>EV 372640871 US</u> , in an envelope addressed to Commissioner for Patents, Alexandria, VA 22313, on the date shown below.	
<u>1-22-04</u> Date of Mailing	<u>Elizabeth Schunacker</u> Signature of person mailing

Sir:

**PRELIMINARY AMENDMENT**

Before examination of the above-identified application, please amend it as follows: